

Fig. 1a

2/14

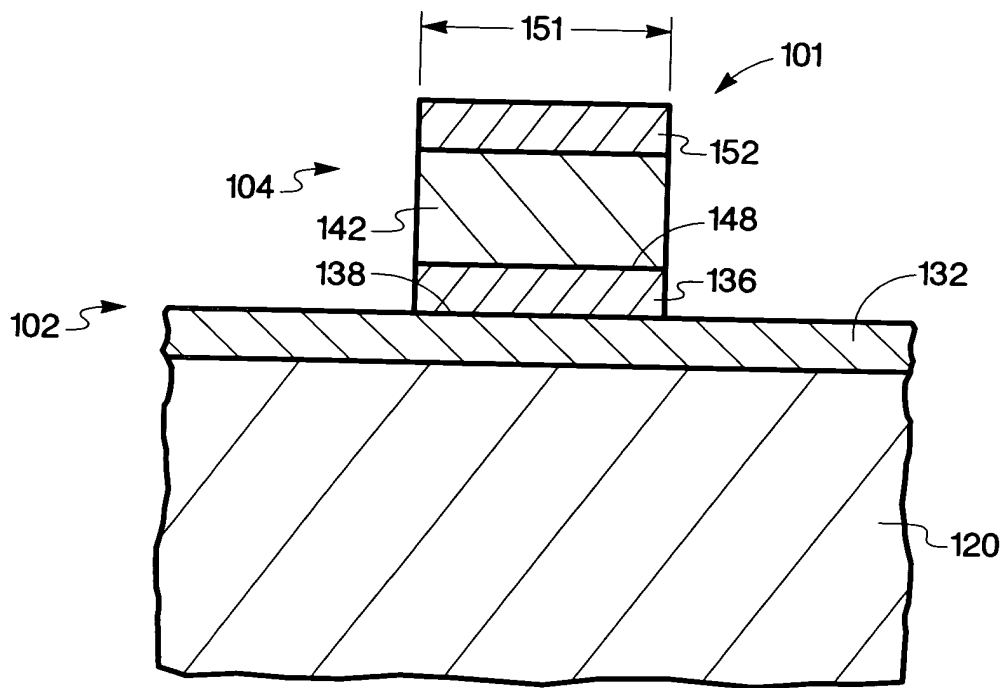


Fig. 1b

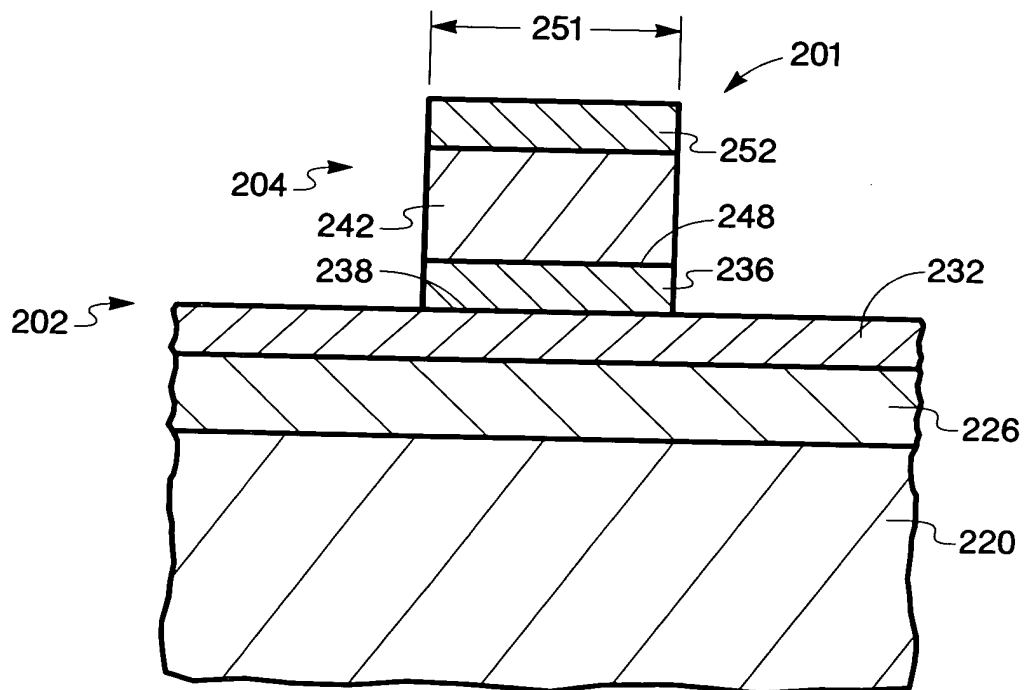


Fig. 2

3/14

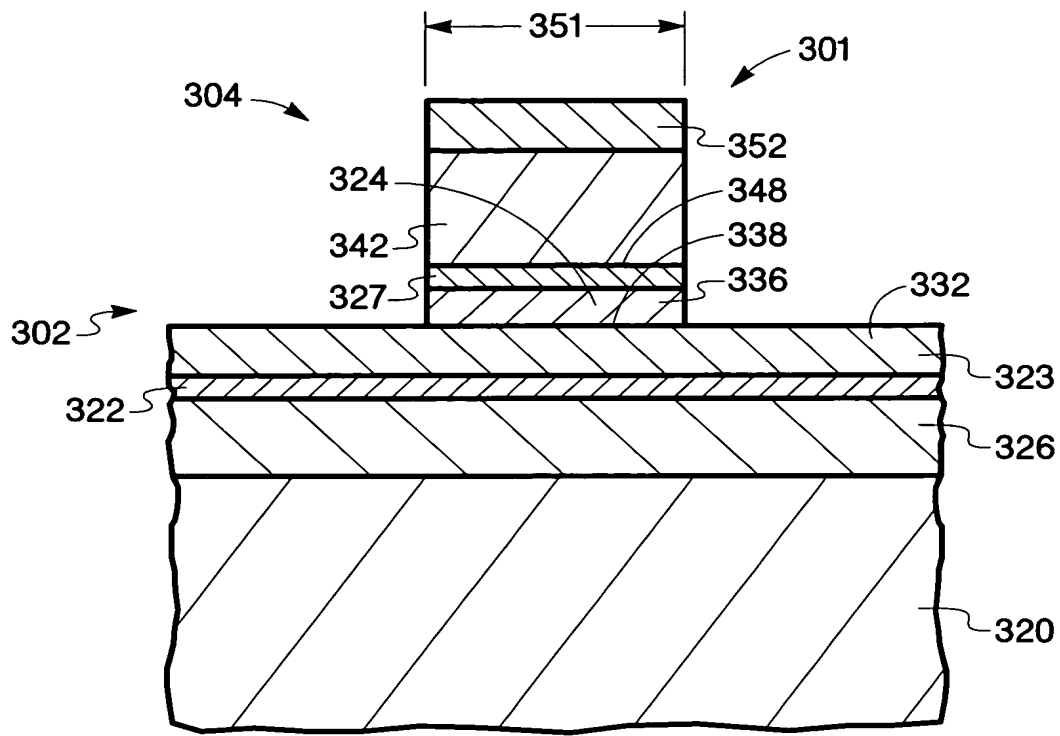


Fig. 3

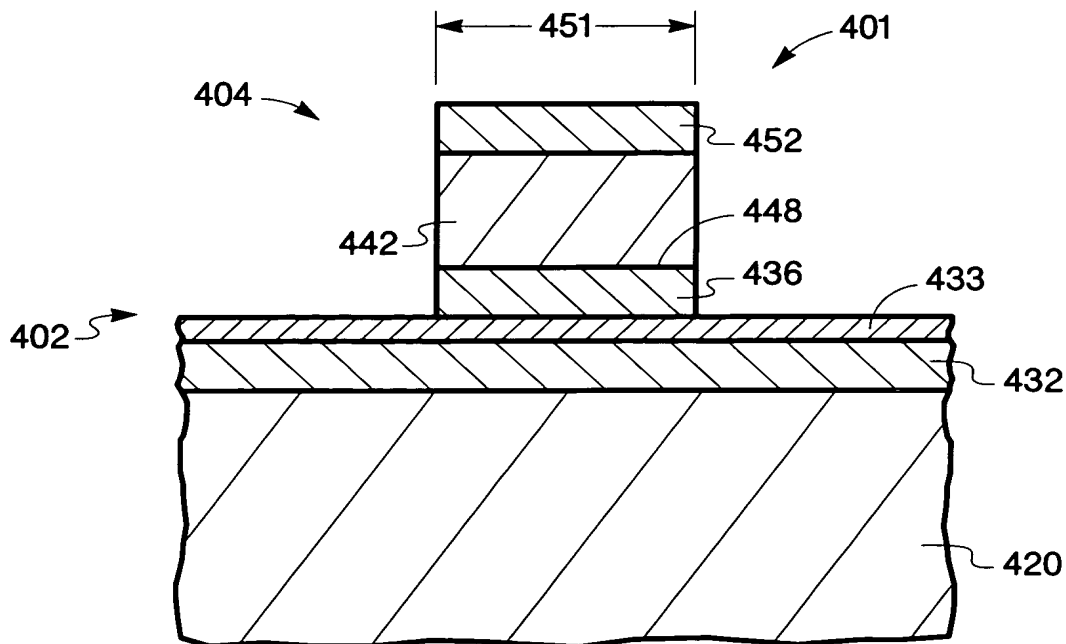
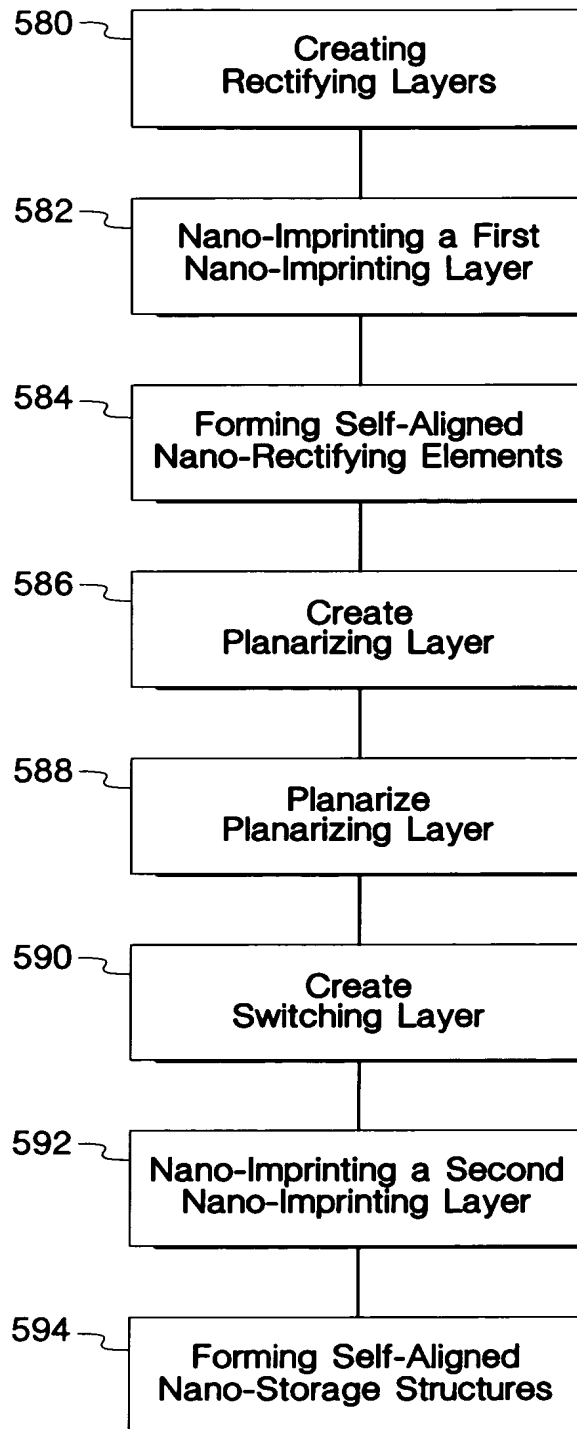


Fig. 4

4/14



**Fig. 5**

5/14

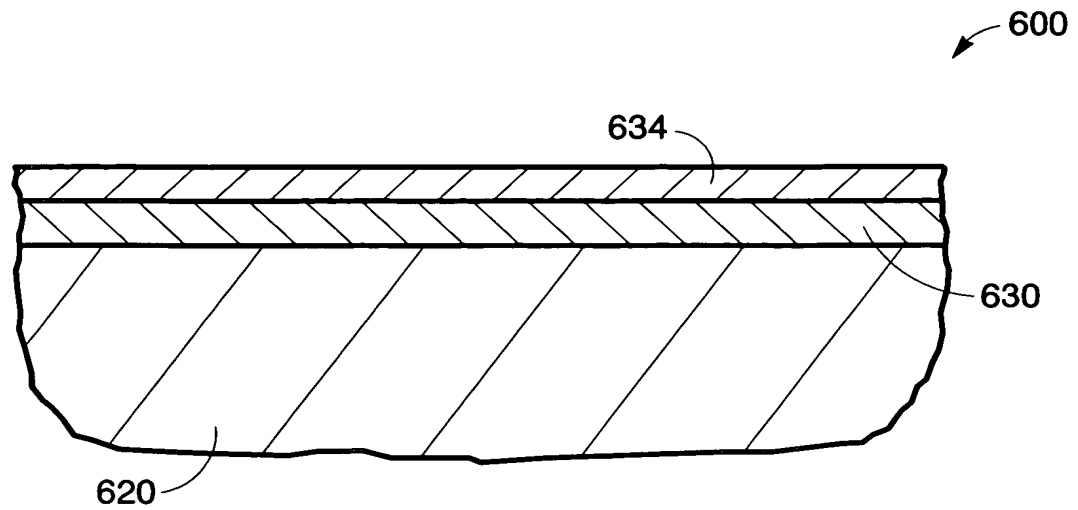


Fig. 6a

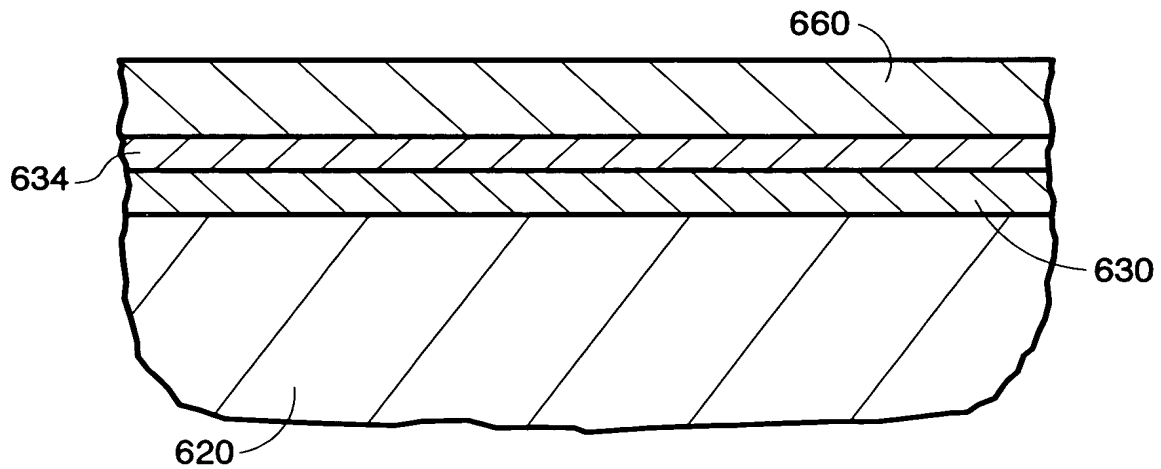


Fig. 6b

6/14

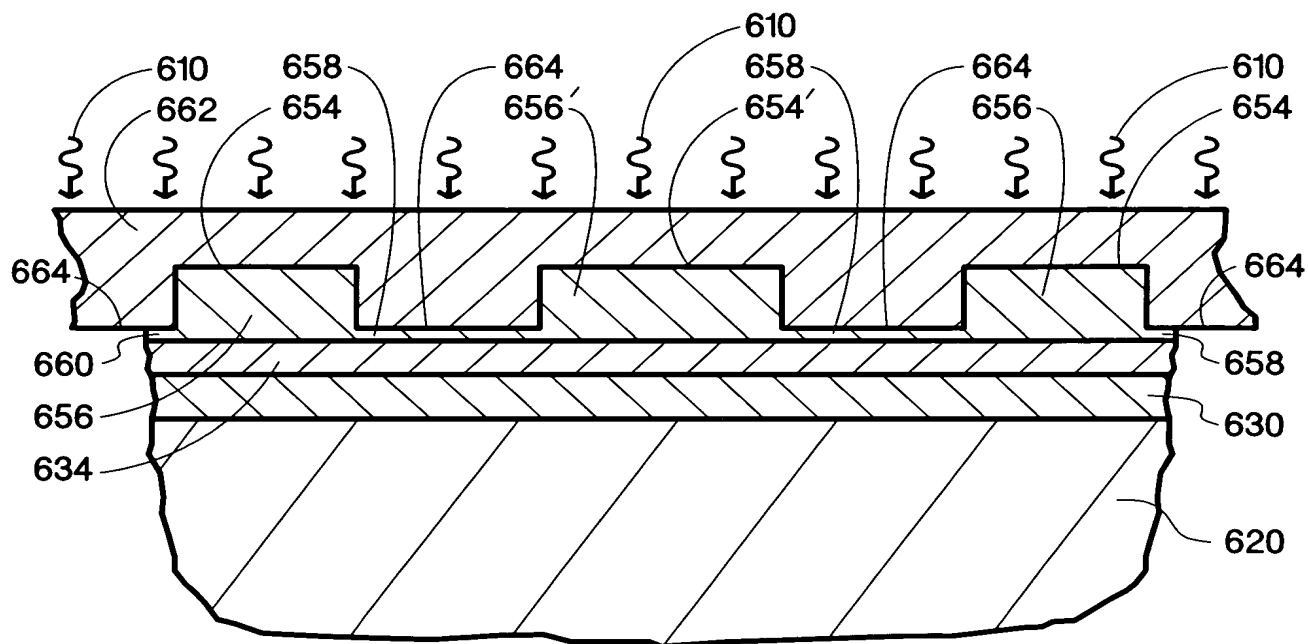


Fig. 6c

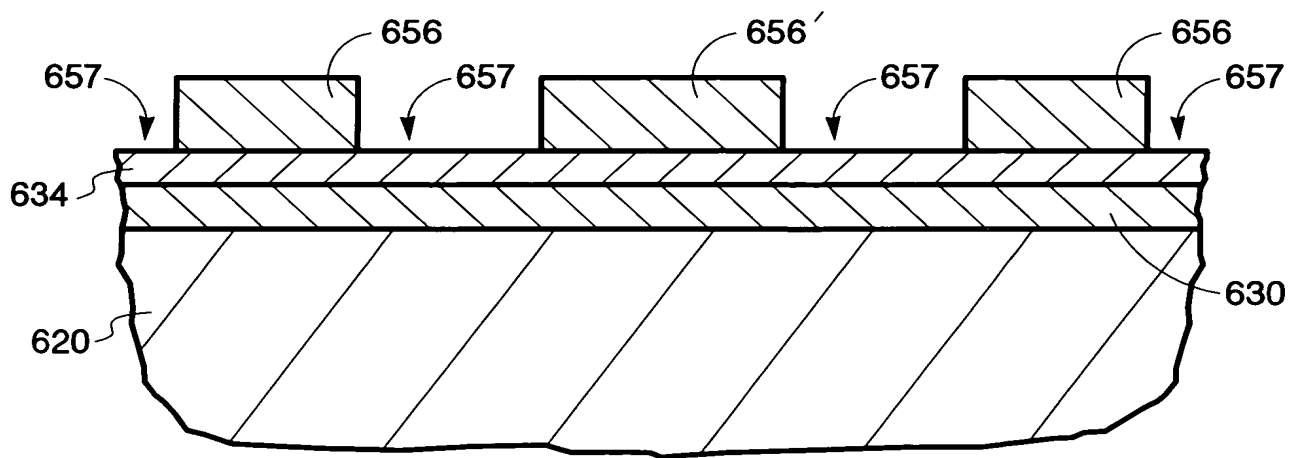
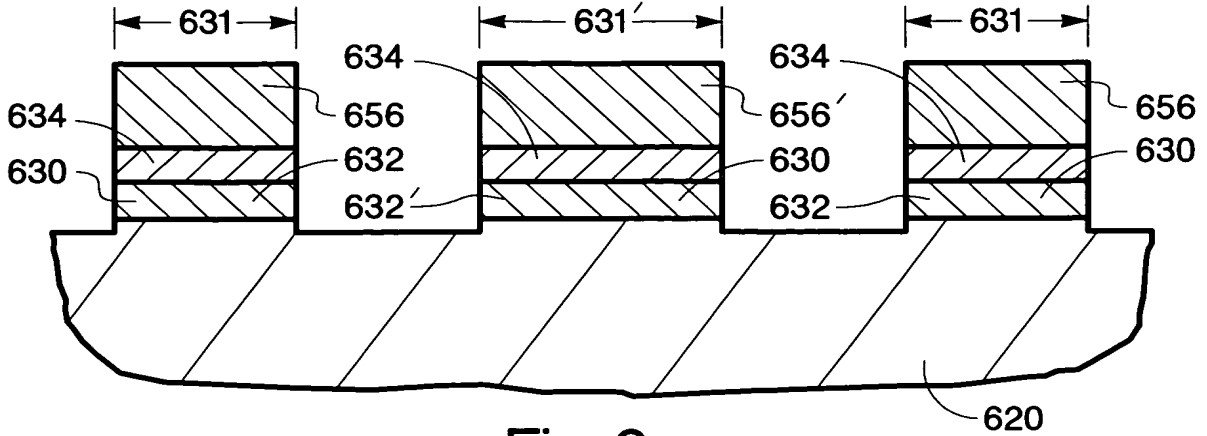
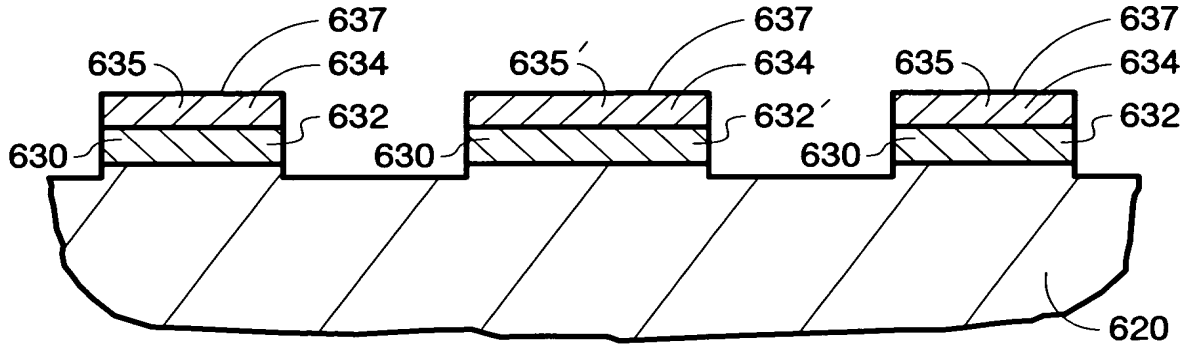


Fig. 6d

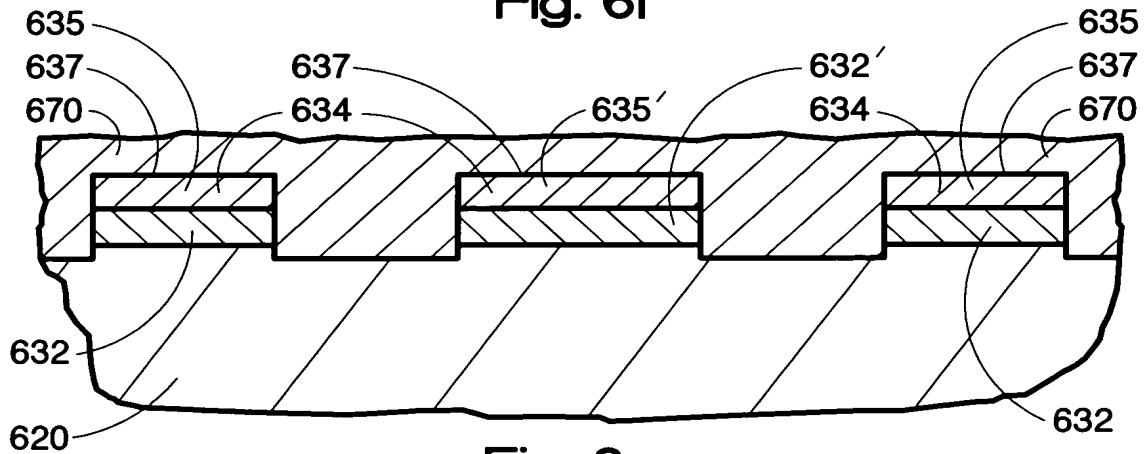
7/14



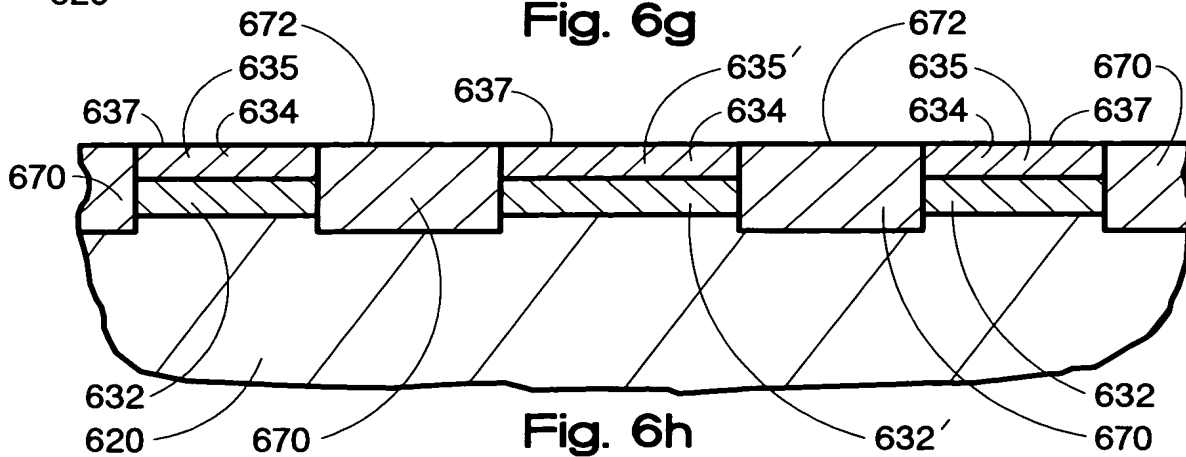
**Fig. 6e**



**Fig. 6f**



**Fig. 6g**



**Fig. 6h**

**Fig. 6i**



9/14

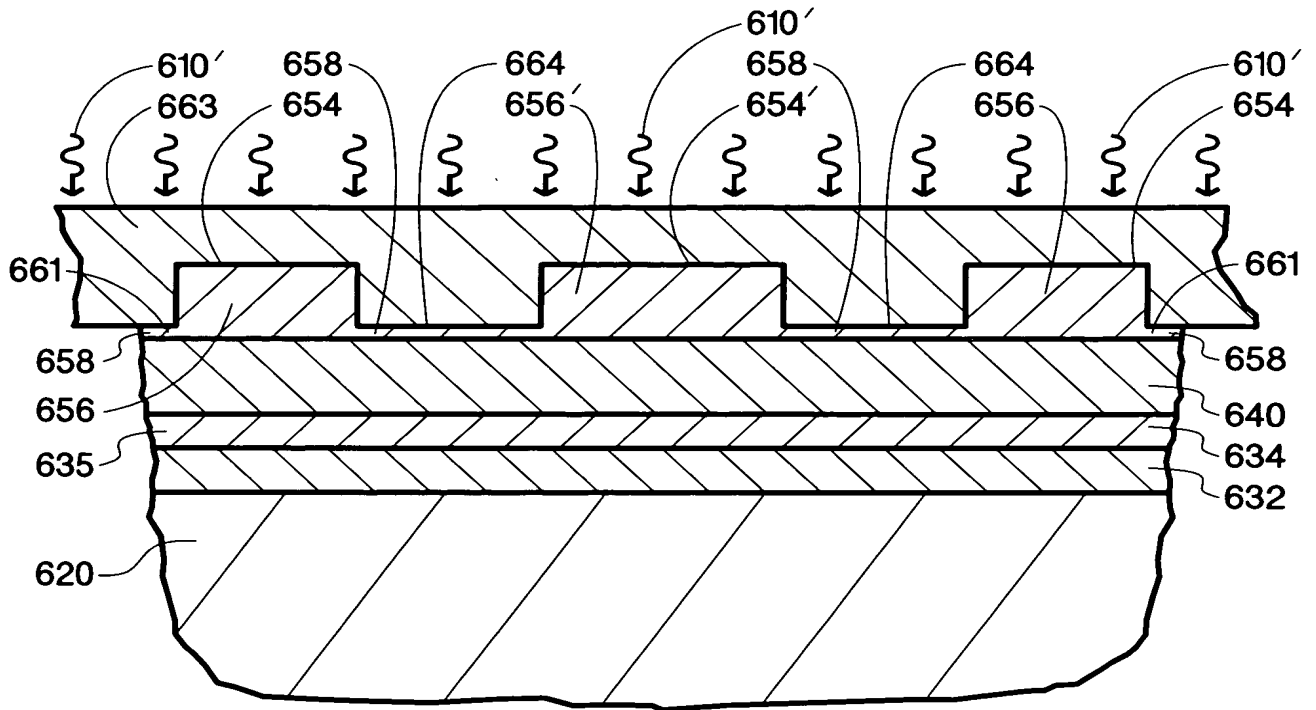


Fig. 6j

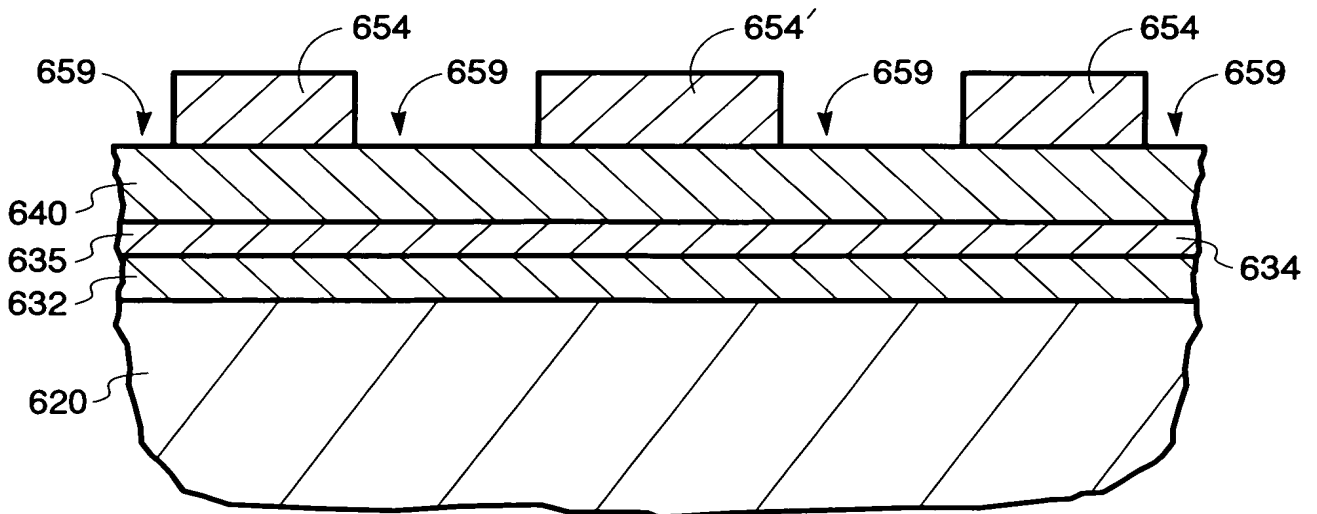


Fig. 6k

NANOMETER-SCALE MEMORY DEVICE UTILIZING  
SELF-ALIGNING RECTIFYING ELEMENTS AND METHOD OF MAKING

James Stasiak, et al.

10/14

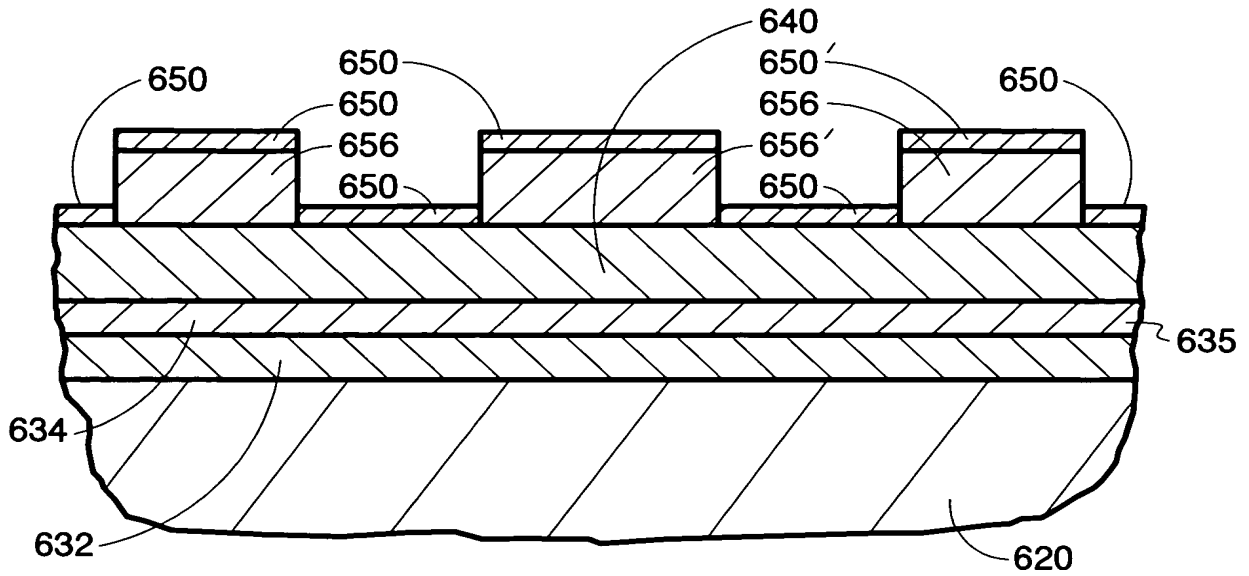


Fig. 6l

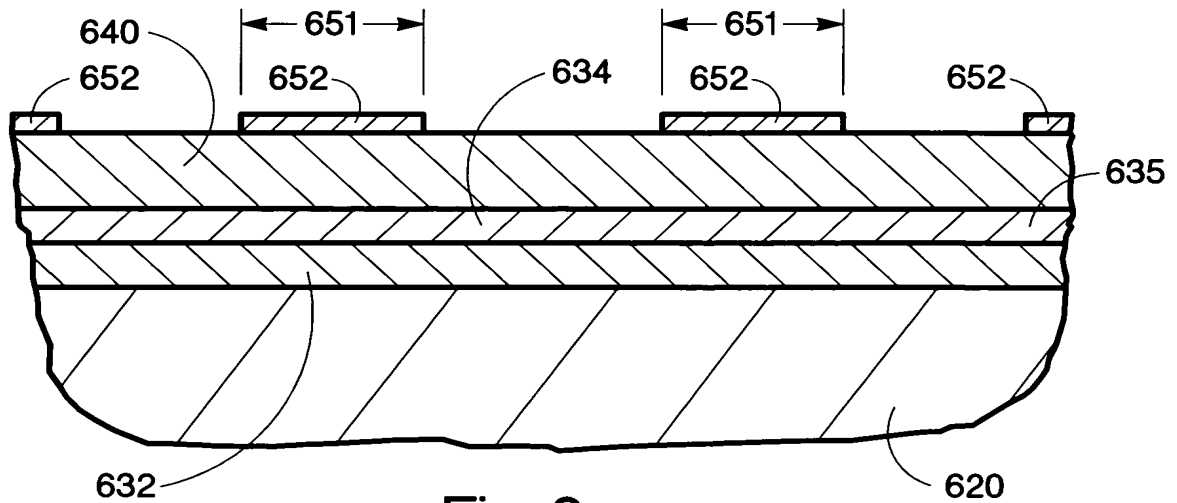


Fig. 6m

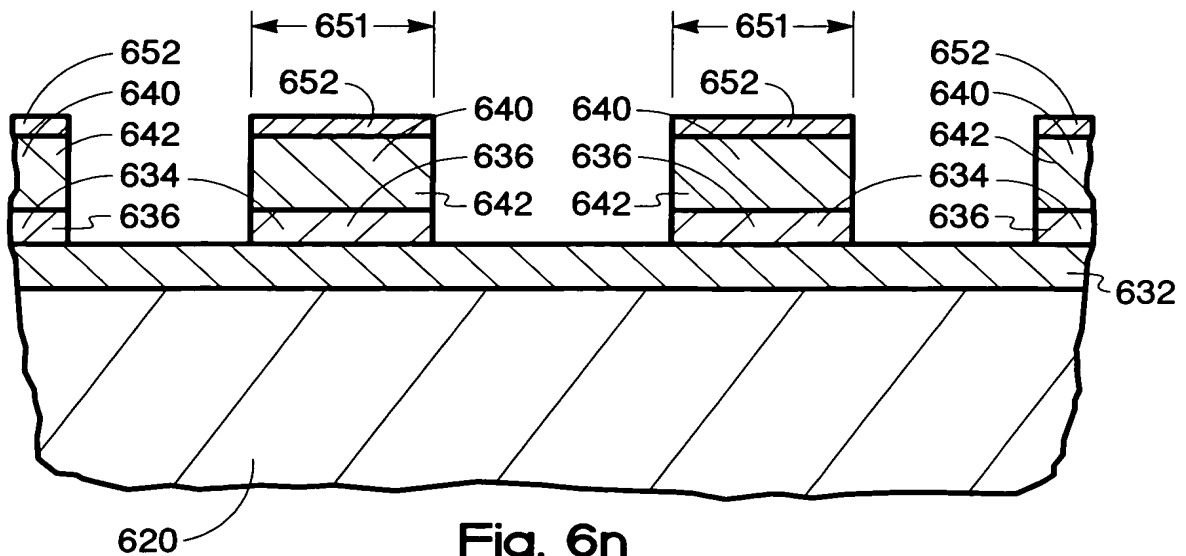
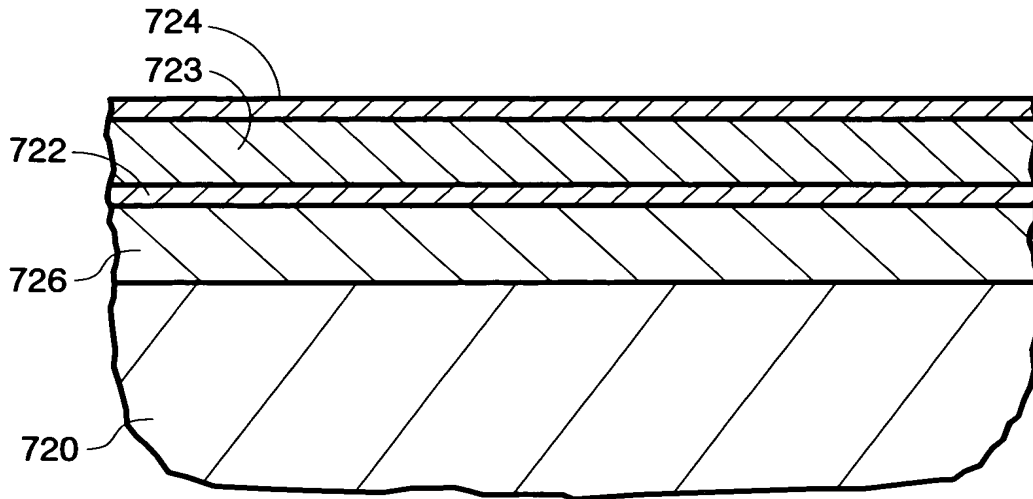
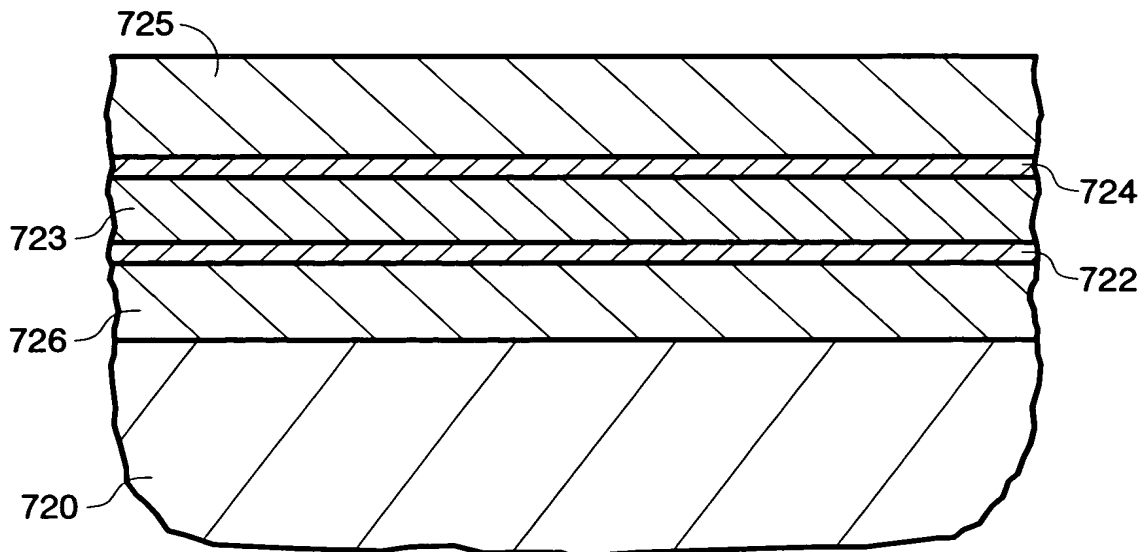


Fig. 6n

11/14



**Fig. 7a**



**Fig. 7b**

12/14

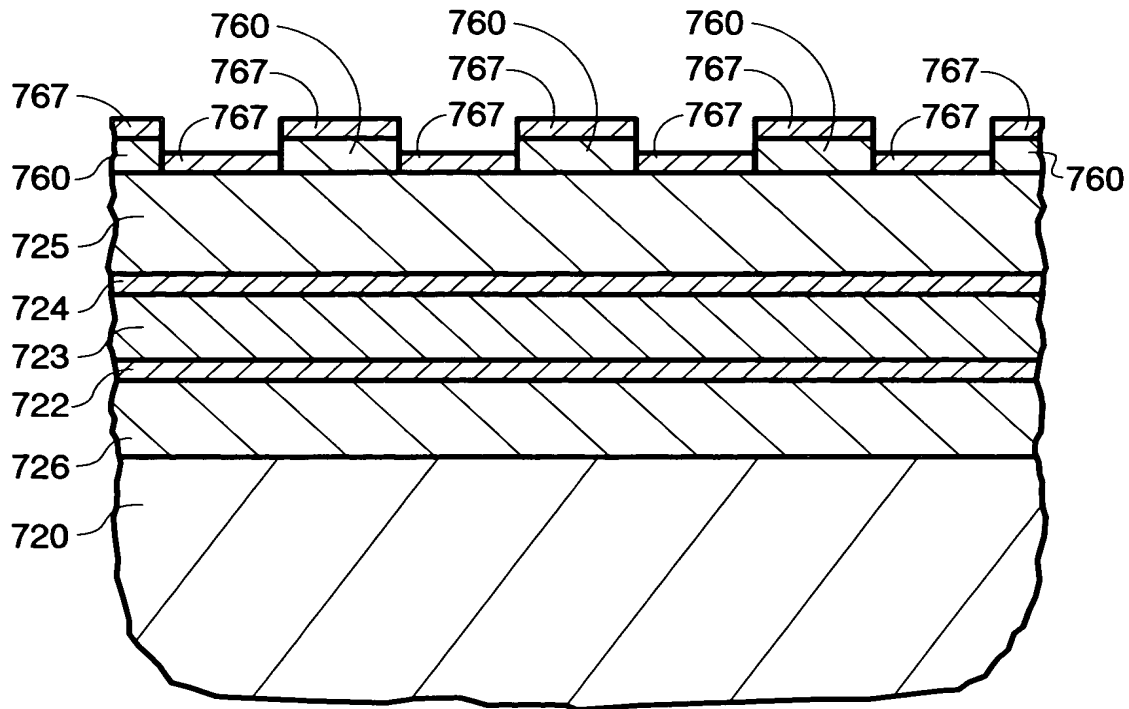


Fig. 7c

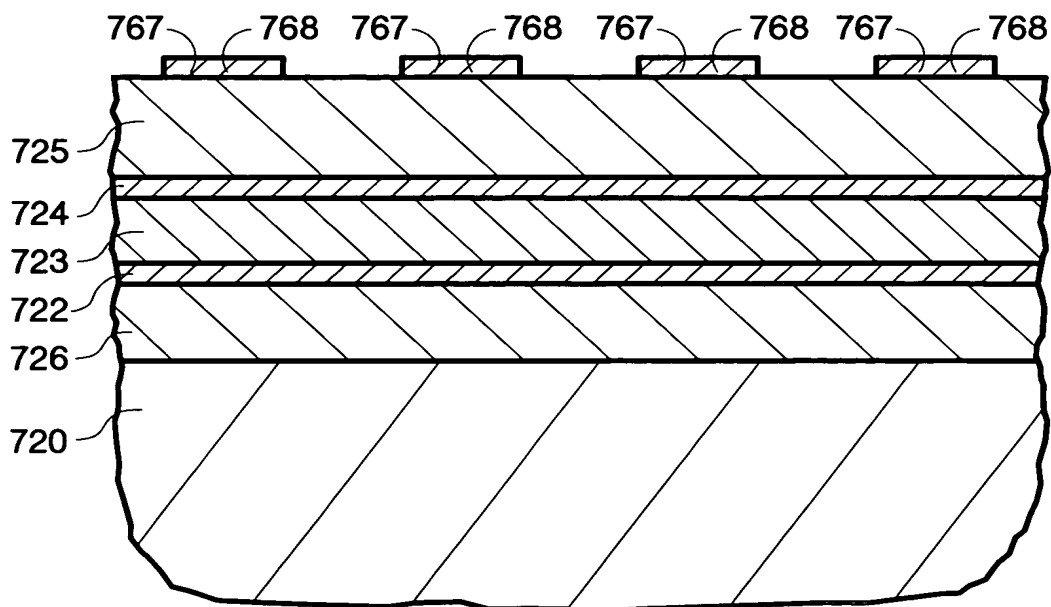


Fig. 7d

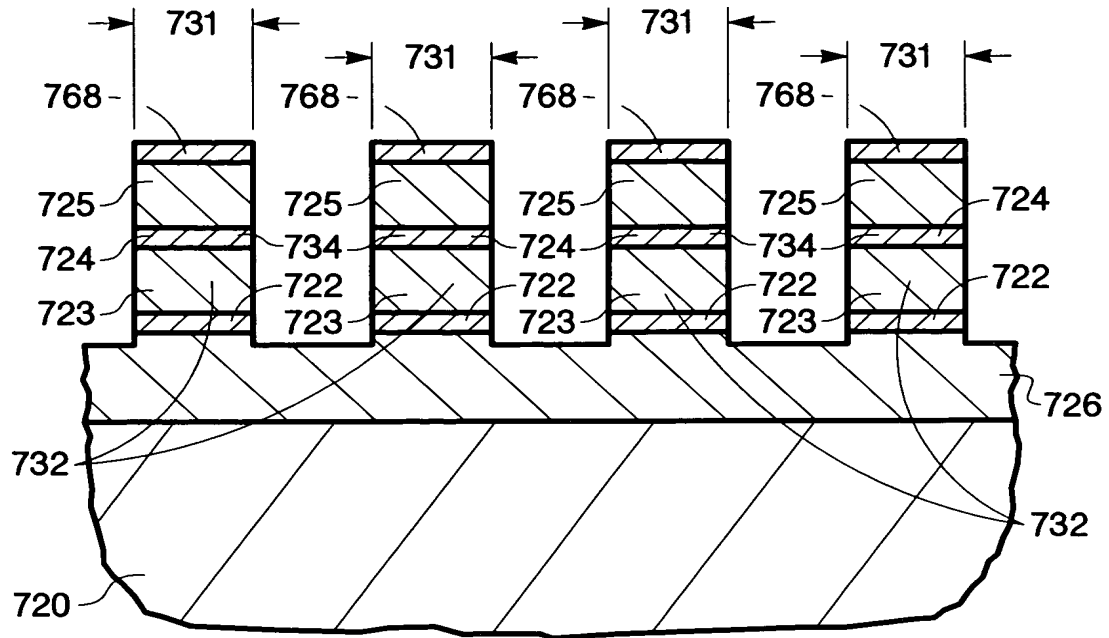


Fig. 7e

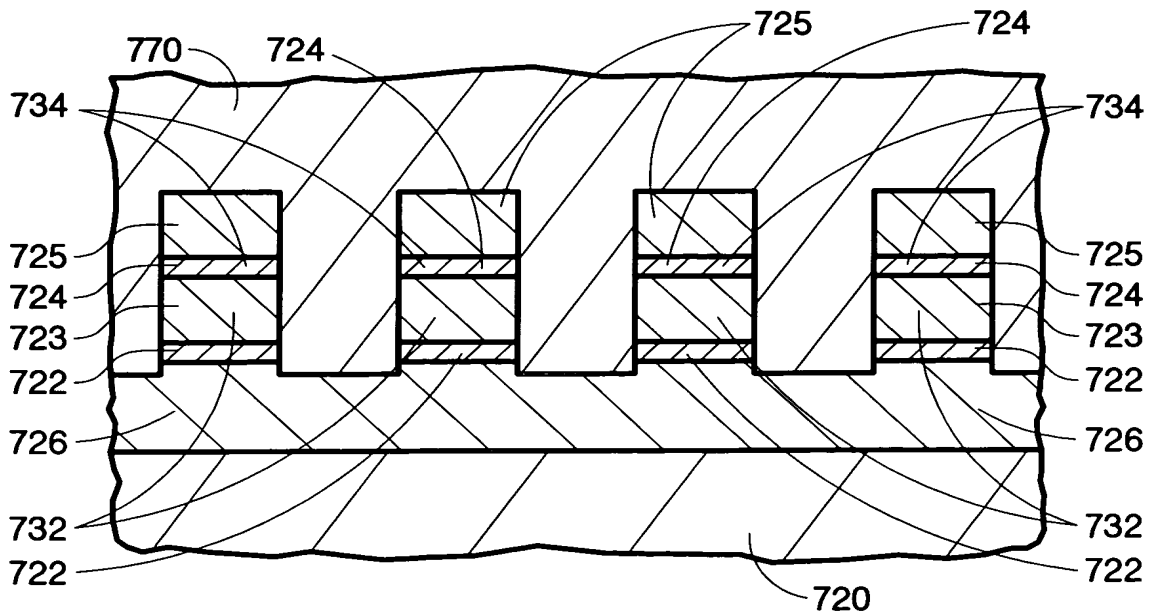


Fig. 7f

**Fig. 7h**